

501.43637X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Kaoru SAKAI et al.
Serial No.: 10/797,011
Filed: March 11, 2004
Title: PATTERN INSPECTION METHOD AND ITS APPARATUS
Group: 2624
Examiner: Jared RADKIEWICZ
Confirmation No.: 3906

RECEIVED
CENTRAL FAX CENTER
JAN 10 2008

AMENDMENT

Mail Stop: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

January 10, 2007

Sir:

In response to the Office Action dated August 10, 2007, the period of response for which extension of time is requested in the attached Petition for Extension of Time, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the claims begin on page 2;

Remarks are included beginning on page 10; and

Authorization is included on page 22.